

<b>Notice of References Cited</b>	Application/Control No. 10/776,016	Applicant(s)/Patent Under Reexamination CHANG, DONG-SOO	
	Examiner Heather A. Doty	Art Unit 2813	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,632,718	10-2003	Grider et al.	438/305
	B	US-2002/0001910	01-2002	CHEN et al.	438/305
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Wolf and R.N. Tauber, Silicon Processing for the VLSI Era, Volume 1, Second Edition, Lattice Press, 2000, pg. 834.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.